

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Wai Fan Yau, et al.

Serial No.: 10/756,122

Confirmation No.: 4554

Filed: January 13, 2004

For: Low Dielectric Constant Film
Produced from Silicon
Compounds Comprising Silicon-
Carbon Bond

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

www.pearsoned.com

Group Art Unit: 2823

Examiner: Julio J. Maldonado

CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence is being electronically transmitted to the U.S. Patent and Trademark Office via EFS-Web on the date shown below.

Date: 5/9/08

Signature:

Keith M. Tackett

INTERVIEW SUMMARY

On May 8, 2008, a telephonic interview was held between Keith M. Tackett, attorney for Applicants, and Examiner Maldonado, during which Examiner Maldonado confirmed the Office Action mailed March 5, 2008 was non-final.

Respectfully submitted,

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